

Electronic Patent Application Fee Transmittal

Application Number:	10553470			
Filing Date:	19-May-2006			
Title of Invention:	MONITORING THE REDUCTION IN THICKNESS AS MATERIAL IS REMOVED FROM A WAFER COMPOSITE AND TEST STRUCTURE FOR MONITORING REMOVAL OF MATERIAL			
First Named Inventor/Applicant Name:	Ralf Lerner			
Filer:	Daniel George Vivarelli/Kim Potter			
Attorney Docket Number:	60291.000041			

Filed as Large Entity

U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Utility Appl Issue fee	1501	1	1510	1510
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
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Total in USD (\$)				1810